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(54) Wafer-level light emitting diode package
Waferebenen-Leuchtdiodengehäuse
Boîtier de diode électroluminescente sur tranche

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Description

Technical Field

[0001] The present invention relates to a light emitting diode (LED) package and a method of fabricating the same, and more particularly, to a wafer level LED package and a method of fabricating the same.

Background Art

[0002] LEDs may be fabricated to be lightweight and slim, and may save energy and have a long lifespan. Accordingly, such LEDs have been widely used as backlight units for a variety of display devices, including mobile phones. LED packages with LEDs mounted thereon, may realize white light having a high color rendering index. Hence, LEDs have replaced white light sources, such as fluorescent lamps, and have been applied to general illumination.

[0003] Generally, a conventional LED package is fabricated by mounting individual LED chips on a package having lead electrodes, connecting the LED chips to the lead electrodes using bonding wires, and encapsulating the LED chips using an encapsulant.

[0004] In such a conventional method of fabricating an LED package, the LED chips are handled individually. Thus, a lot of time and expense are required for the mass production of LED packages, leading to lower productivity. Furthermore, since the bonding wires are formed again after the LED chips are mounted, the process of fabricating the LED package is complicated. In addition, since the wire bonding process using capillaries requires a space for movement of the capillaries, it acts as a limitation to reducing a package size. Moreover, package failure may be frequently caused by a bonding failure or disconnection of wires.

[0005] As a size of a growth substrate for growing an epitaxial layer has recently been increased from 2 inches to 4 inches, even up to 6 inches, thousands to ten thousands of LED chips have been fabricated on a single growth substrate. Therefore, there are increasing demands for fabricating LED packages in large quantities and rapidly by using those LED chips. However, the prior art has difficulty in meeting the above-described demands. US 2009/179207 A1 (CHITNIS ASHAY [US] ET AL; pub. date: 16 July 2009) discloses a wafer-level light emitting diode package having a wavelength converter covering a substrate surface.

Disclosure

Technical Problem

[0006] Exemplary embodiments of the present invention provide an LED package, which is suitable for mass production through a simplified process, and a method of fabricating the same.
The formation of the underfill may include: forming a B-stage underfill on the first substrate to cover the plurality of semiconductor stacks; and curing the B-stage underfill while the first and second bumps are bonded to the first and second lead electrodes. An underfill material may be coated on the first substrate using a spin coating or lamination. Afterwards, the underfill material may become a B-stage on the first substrate.

Meanwhile, a wavelength converter covering a rear surface of the first substrate may be formed after the coupling is completed. The wavelength converter may be formed to cover a lateral side of the first substrate after the cutting of the first substrate. The method may further include partially removing a portion of the underfill disposed under a cut region after the cutting of the first substrate, wherein the wavelength converter is formed to cover a lateral side exposed by the partial removal of the underfill.

The method may further include forming a moisture barrier coating covering the wavelength converter. The moisture barrier coating may block the penetration of water or moisture to protect the wavelength converter. Furthermore, the moisture barrier coating may protect the semiconductor stacks. The moisture barrier coating may be formed of silicon oxide or silicon nitride capable of blocking the penetration of moisture. In addition, the moisture barrier coating may be formed by alternately laminating an organic material layer and an inorganic material layer. By alternately laminating the organic material layer and the inorganic material layer, the moisture barrier coating may lengthen the penetration path of moisture penetrating from the outside, and thus, may prevent moisture from penetrating into the wavelength converter.

In some embodiments, the wavelength converter may be a phosphor-containing epoxy or silicone resin. In other embodiments, the wavelength converter may be a phosphor-containing glass. The glass may be attached to the rear surface of the first substrate using an adhesive, or may be attached to the rear surface of the first substrate using a low-temperature direct bonding. If the low-temperature direct bonding is used, optical loss caused by the adhesive may be prevented.

In some embodiments, the wavelength converter may be formed after the cutting of the first substrate. Furthermore, the wavelength converter may fill a gap between the plurality of semiconductor stacks and the second substrate. That is, the wavelength converter and the underfill may be formed at the same time.

The method may further include: cutting the wavelength converter on a package basis by removing the wavelength converter disposed under the cut region of the first substrate; and forming a moisture barrier coating covering the cut wavelength converter.

The method may further include forming a surface texture on a rear surface of the first substrate so as to improve a light extraction efficiency. The surface texture may be formed using wet etching, electron beam lithography, or nano implant technique.

In addition, the first substrate may be cut such that a lateral side of the first substrate is inclined with respect to a vertical direction of a rear surface of the first substrate. Accordingly, the light extraction efficiency may be further improved.

Another exemplary embodiment of the present invention provides a wafer level LED package, which includes: a first substrate; a semiconductor stack disposed on a front surface of the first substrate, the semiconductor stack comprising a first-conductivity-type semiconductor layer, a second-conductivity-type semiconductor layer, and an active layer disposed between the first-conductivity-type semiconductor layer and the second-conductivity-type semiconductor layer; a second substrate comprising a first lead electrode and a second lead electrode; a plurality of connectors electrically connecting the semiconductor stack to the first and second lead electrodes; and a wavelength converter covering a rear surface of the first substrate.

As opposed to the conventional LED package in which individual chips are mounted, the wafer level LED package may be fabricated by mounting the first substrate, on which the plurality of semiconductor stacks are formed, on the second substrate, and cutting the first substrate and the second substrate. Therefore, the sizes of the first substrate and the second substrate within the wafer level LED package are almost similar. Hence, the small-sized LED packages may be provided.

Meanwhile, an underfill may be disposed between the first substrate and the second substrate. The underfill may reinforce the bonding force of the semiconductor stacks and the second substrate, thereby preventing the semiconductor stacks from being separated from the second substrate. Furthermore, the underfill may include at least one of a phosphor and a filler.

In addition, the wavelength converter may cover at least a portion of a lateral side of the underfill.

Meanwhile, a moisture barrier coating may cover the wavelength converter. Therefore, it may be possible to prevent moisture from penetrating from the outside into the wavelength converter. Furthermore, the moisture barrier coating may cover a lateral side of the underfill.

The moisture barrier coating may have a structure in which an organic material layer and an inorganic material layer are alternately laminated. The moisture barrier coating may lengthen a moisture penetration path, thereby making it difficult for moisture to penetrate into the wafer level LED package.

Meanwhile, the wavelength converter may fill a gap between the first substrate and the second substrate. That is, the underfill may be formed of the same material as the wavelength converter by the same process.

In some embodiments, the wavelength converter may include a phosphor-containing glass. The glass may be directly bonded to the rear surface of the first substrate. That is, the glass may be attached to the first substrate, without using an adhesive. Therefore, optical loss due to the use of the adhesive may be prevented.
Meanwhile, a surface texture for improving a light extraction efficiency may be formed on the rear surface of the first substrate. A lateral side of the first substrate may be inclined with respect to a vertical direction of the back side of the first substrate.

Advantageous Effects

According to the present invention, the plurality of semiconductor stacks formed on the first substrate are coupled to the second substrate at a wafer level, and the first substrate and the second substrate are cut to fabricate the LED packages. Therefore, the chip bonding process may be simplified and the working time may be considerably reduced. Furthermore, since the LED packages are fabricated at a wafer level, it is suitable for package miniaturization. Moreover, the underfill may improve the bonding force of the first substrate and the second substrate. Therefore, the structurally stable LED packages may be provided. By forming the moisture barrier layer, it may be possible to prevent moisture from penetrating from the outside into the LED package.

In addition, mixed color light, particularly white light, may be realized using the wavelength converter. Using the underfill and/or the wavelength converter, the wavelength conversion may be performed on light emitted toward the lateral sides and bottom surfaces of the semiconductor stack, as well as the top surfaces thereof.

Summary of the Invention

The invention discloses a wafer level light emitting diode package according to claim 1. Further embodiments are disclosed in the dependent claims.

Description of Drawings

FIGS. 1 to 7 are cross-sectional views illustrating a method of fabricating an LED package according to an embodiment of the present invention.

FIGS. 8 to 12 are cross-sectional views illustrating a method of fabricating an LED package according to another embodiment of the present invention.

FIGS. 13 to 16 are cross-sectional views illustrating a method of fabricating an LED package according to an embodiment of the present invention.

Mode for Invention

Exemplary embodiments of the present invention will be described below in detail with reference to the accompanying drawings. These embodiments are provided so that this disclosure will be thorough and complete, and will fully convey the scope of the invention to those skilled in the art. The invention may, however, be embodied in many different forms and should not be construed as being limited to the embodiments set forth herein. In the drawings, the widths, lengths and thicknesses of elements may be exaggerated for clarity. Throughout the drawings and written description, like reference numerals will be used to refer to like elements.

It will be understood that when an element, such as a layer, a region, or a substrate, is referred to as being "on," "connected to," or "coupled to" another element, it may be directly on, connected or coupled to the other element, or intervening elements may be present.

FIGS. 1 to 7 are cross-sectional views illustrating a method of fabricating an LED package according to an embodiment of the present invention.

(Preparation of Wafer 20)

Referring to FIG. 1, a wafer 20, in which a plurality of semiconductor stacks 30 are formed on a first substrate 21, is prepared.

The wafer 20 includes the first substrate 21, and the plurality of semiconductor stacks 30 arranged on the first substrate 21. In addition, the wafer 20 may further include an ohmic contact layer 31, an insulation layer 33, first electrodes 36a, second electrodes 36b, an underfill 40a, and a buffer layer (not shown). Each of the semiconductor stacks 30 may include a first-conductivity-type semiconductor layer 29, an active layer 27, and a second-conductivity-type semiconductor layer 29. In addition, the first electrode 36a may include a first electrode pad 35a and a first bump 37a, and the second electrode 36b may include a second electrode pad 35b and a second bump 37b.

The first substrate 21 may be a growth substrate capable of growing a nitride semiconductor layer. For example, the first substrate 21 may be a sapphire substrate, a silicon carbide substrate, or a spinel substrate. The first substrate 21 is a transparent substrate capable of transmitting light.

The semiconductor stacks 30 may be fabricated through a typical LED chip fabricating process. That is, epitaxial layers, which include the first-conductivity-type semiconductor layer 25, the active layer 27, and the second-conductivity-type semiconductor layer 29, are grown on the first substrate 21 and are patterned to form the plurality of semiconductor stacks 30 on the first substrate 21. In order to expose a portion of the first-conductivity-type semiconductor layer 25, the second-conductivity-type semiconductor layer 29 and the active layer 27 may also be partially removed.

The active layer 27, the first-conductivity-type semiconductor layer 25, and the second-conductivity-type semiconductor layer 29 may be formed of group III-N compound semiconductors, for example, (Al, Ga, In)N semiconductors. The first-conductivity-type semiconductor layer 25 and the second-conductivity-type semiconductor layer 29 may be a single layer or a multiple-layer. For example, the first-conductivity-type semiconductor layer 25 and/or the second-conductivity-type semi-
iconductor layer 29 may include a contact layer and a clad layer. In addition, the first-conductivity-type semiconductor layer 25 and/or the second-conductivity-type semiconductor layer 29 may include a superlattice layer. Moreover, the active layer 27 may have a single quantum well structure or a multiple quantum well structure. For example, the first conductivity type may be an n type and the second conductivity type may be a p type; however, the invention is not limited thereto. The first conductivity type may be a p type and the second conductivity type may be an n type. The buffer layer (not shown) alleviates a lattice mismatch between the first substrate 21 and the first-conductivity-type semiconductor layer 25, leading to a reduction in defect density occurring within the semiconductor layers 25, 27 and 29.

Meanwhile, the ohmic contact layer 31 may be formed on the second-conductivity-type semiconductor layer 29. The first electrode pad 35a and the second electrode pad 35b may be formed on the first-conductivity-type semiconductor layer 25 and the second-conductivity-type semiconductor layer 29, respectively. For example, the ohmic contact layer 31 may include a transparent conductive layer, such as Ni/Au, indium tin oxide (ITO), indium zinc oxide (IZO), or ZnO; however, the invention is not limited thereto. The ohmic contact layer 31 may include a reflective metal layer. The first electrode pad 35a and the second electrode pad 35b may include one or more materials selected from Ti, Cu, Ni, Al, Au, and Cr. The second electrode pad 35b may be electrically connected to the second-conductivity-type semiconductor layer 29 through the ohmic contact layer 31. Before the first and second electrode pads 35a and 35b are formed, the insulation layer 33 covering the semiconductor stacks 30 may also be formed. The insulation layer 33 may be formed of silicon oxide or silicon nitride.

Furthermore, the first bump 37a and the second bump 37b may be formed on the first electrode pad 35a and the second electrode pad 35b, respectively. The first bump 37a and the second bump 37b are connectors that electrically connect the plurality of semiconductor stacks 30 to first and second lead electrodes 53a and 53b of a second substrate 51. The first bump 37a and the second bump 37b structurally connect the plurality of semiconductor stacks to the second substrate 51.

The first bump 37a and the second bump 37b may be formed of Au or a solder. Alternatively, after a bump is formed of a rigid metal such as Ni or Ni alloy, Au or a solder may be formed on the bump. In addition, the first bump 37a and the second bump 37b may be formed of a stud bump using a wire bonding technique.

Meanwhile, the underfill 40a may be formed on the first substrate 21, on which the semiconductor stacks 30 are formed. The underfill 40a may be formed of a thermosetting resin or a thermoplastic resin. In addition, the underfill 40a may include a phosphor and/or a filler. The phosphor may be added for converting light emitted toward the lateral sides of the semiconductor stacks 30, and the filler may be added for adjusting a coefficient of thermal expansion and a modulus of elasticity of the underfill 40a. For example, the underfill 40a may be formed using a spin coating or lamination technique. For example, the underfill 40a may be formed using a screen printing technique employing a squeeze. Accordingly, the underfill 40a may be formed to cover the lateral sides and the top surfaces of the semiconductor stacks 30. The first and second bumps 37a and 37b may pass through the underfill 40a and be exposed to the outside.

The underfill 40a may be cured in the step of preparing the wafer 20; however, the invention is not limited thereto. The underfill 40a may remain in a B-stage state in the step of preparing the wafer 20. Thereafter, while bonding the first and second bumps 37a and 37b to the lead electrodes 53a and 53b of the second substrate 21, the B-stage underfill 40a may be cured.

(Coupling of Wafer 20 and Package Member 50)

Referring to FIG. 2, the second substrate 51 including the first lead electrodes 53a and the second lead electrodes 53b is prepared as a package member 50.

The second substrate 51 may be a printed circuit board (PCB) on which the lead electrodes 53a and 53b are printed. For example, the second substrate 51 may be an organic PCB such as an FR4 PCB, a metal PCB, a metal core PCB, a ceramic substrate, a Si substrate, an AlN substrate, or a SiC substrate.

In a case where the second substrate 51 is a conductive substrate such as a metal PCB, the lead electrodes 53a and 53b may be insulated from the conductive substrate by an insulation layer (not shown).

The first and second lead electrodes 53a and 53b may have internal terminals or pads on the second substrate 51, and may have external terminals under the second substrate 51 in order for connection to an external power supply. The first and second lead electrodes 53a and 53b pass through the second substrate 51. The first and second lead electrodes 53a and 53b may fill through-holes of the second substrate 51; however, the invention is not limited thereto. The first and second lead electrodes 53a and 53b may be formed along the lateral sides of the through-holes.

(Coupling of Wafer 20 and Package Member 50)
Meanwhile, for example, in a case where the first and second bumps 37a and 37b are bonded by a thermocompression bonding, a temperature profile of a thermocompression bonding process may be adjusted to reduce a viscosity of the B-stage underfill 40a when a metal bonding is in progress, causing the B-stage underfill 40a to flow. Thereafter, while a temperature is maintained or decreased, a process of curing the B-stage underfill 40a may be carried out. Accordingly, the underfill 40a may reinforce the coupling of the wafer 20 and the package member 50. Furthermore, the filler may be added to the underfill 40a, so that the underfill 40a can reduce a difference in coefficient of thermal expansion between the wafer 20 and the package member 50. Therefore, the underfill 40a may improve the structural stability and reliability of the LED package.

Meanwhile, after the coupling, a rear surface of the first substrate 21 may be partially removed by grinding, and thus, the first substrate 21 may become thin.

(Formation of Wavelength Converter 60)

Referring to FIG. 4, after the coupling process is completed, a wavelength converter 60 is formed on the rear surface of the first substrate 21. The wavelength converter 60 may be formed by coating a phosphor or a phosphor-containing resin. For example, the phosphor-containing resin may be coated on the first substrate 21, and the wavelength converter 60 may be formed at a uniform thickness using a squeeze. Alternatively, a phosphor-containing wavelength converter, for example, a glass, may be formed on the first substrate 21. The glass may be attached to the first substrate 21 using an adhesive. Also, the glass may be attached to the first substrate 21 using a low-temperature direct bonding technique, without using an adhesive.

(Cutting Process)

Referring to FIG. 5, the first substrate 21 and the second substrate 51 are cut. In a case where the underfill 40a is formed, the underfill 40a is also cut. The first substrate 21 and the second substrate 51 may be cut by scribing, braking, sawing, or laser. As a result, the fabrication of individual LED packages is completed.

The first substrate 21 and the second substrate 51 may be cut using a laser in the same process. Accordingly, the first substrate 21 and the second substrate 51 may be formed to have substantially the same size; however, the invention is not limited thereto. After the first substrate 21 is cut, the second substrate 51 may be cut through a separate process. In this case, as illustrated in FIG. 5, the first substrate 21 may be slightly smaller in size than the second substrate 51.

Meanwhile, phosphor characteristics of the phosphor-containing wavelength converter 60 are easily changed by moisture penetrated from the outside. In particular, in a case where the wavelength converter 60 is formed of a silicone resin, it is necessary to protect the silicone resin and the phosphor from moisture penetrated from the outside. To this end, as illustrated in FIG. 6, a moisture barrier coating 70 is formed to cover the wavelength converter 60.

Before the cutting of the first substrate 21, the moisture barrier coating 70 may be formed on the first substrate 21 to cover the wavelength converter 60. Thereafter, the moisture barrier coating 70 may be cut together with the first substrate 21. Alternatively, the moisture barrier coating 70 may be formed after the cutting of the first substrate 21 and the underfill 40a, or may be formed after the cutting of the second substrate 51. Therefore, the moisture barrier coating 70 covers the wavelength converter 60 and the lateral side of the underfill 40a, thereby preventing moisture from penetrating from the outside into the LED package.

For example, the moisture barrier coating 70 may include a silicon oxide film or a silicon nitride film. As illustrated in FIG. 7, the moisture barrier coating 70 may be formed by alternately laminating an organic material layer 71 and an inorganic material layer 73. For example, the moisture barrier coating 70 may be formed by alternately laminating a transparent polymer and an oxide or nitride of a metal such as silicon (Si) or aluminum (Al) using a low-temperature vacuum deposition. The moisture barrier coating 70 lengthens a moisture penetration path to prevent moisture from penetrating into the wavelength converter 60.

According to this embodiment, since the plurality of semiconductor stacks 30 are mounted on the package member 50 at a wafer level, a fabrication process may be simplified and a fabrication cost may be reduced, as compared to a conventional fabricating process which mounts individual chips. Furthermore, in a package fabricating process, it is unnecessary to electrically connect the lead electrodes to the semiconductor stacks using bonding wires. Therefore, it may be possible to avoid a package failure caused by breakage or shorting of bonding wires.

Although it has been described above that the underfill 40a is formed to cover the plurality of semiconductor stacks 30 before the bonding of the wafer 20 and the package member 50, the underfill 40a may not be needed in all aspects. Moreover, after the coupling of the wafer 20 and the package member 50, the underfill 40a may be formed by injecting an underfill material into a gap between the first substrate 21 and the second substrate 51.

FIGS. 8 to 12 are cross-sectional views illustrating a method of fabricating an LED package according to another embodiment of the present invention.

Referring to FIG. 8, a wafer 20 and a package member 50 are prepared and coupled to each other, as described above with reference to FIGS. 1 to 3. Thereafter, a surface texture T is formed on a rear surface of the first substrate 21. The surface texture T may be formed by etching the first substrate 21 using wet etching,
electron beam lithography, or nano implant technique. For example, the surface texture T may be formed with patterns having a pitch ranging from tens of nanometers to several micrometers and having an aspect ratio of 1 or more. The surface texture T may improve a light extraction efficiency of light emitted from the semiconductor stacks 30.

[0066] Referring to FIG. 9, the first substrate 21 is cut. The first substrate 21 may be cut to have an inverted triangular cross-section by using a diamond blade or a laser. Therefore, as illustrated in FIG. 9, in the cut region, the lateral side of the first substrate 21 may be formed to be inclined with respect to a vertical direction of the rear surface of the first substrate 21. The inclined lateral side of the first substrate 21 may improve a light extraction efficiency of light emitted from the semiconductor stacks 30.

[0067] Meanwhile, an underfill 40a under the cut region may be partially removed. The underfill 40a may be removed such that a portion thereof remains on the second substrate 51; however, the invention is not limited thereto. The underfill 40a may be removed such that the surface of the second substrate 51 is exposed.

[0068] Referring to FIG. 10, a wavelength converter 60a covering the first substrate 21 is formed. The wavelength converter 60a may be formed of a phosphor-containing resin. The wavelength converter 60a covers the rear surface and the lateral side of the first substrate 21, and also covers the lateral side of the underfill 40a exposed within the cut region.

[0069] Referring to FIG. 11, the second substrate 21 is cut, and therefore, the fabrication of individual LED packages is completed. The wavelength converter 60a and the remaining underfill 40a under the cut region may also be cut.

[0070] Referring to FIG. 12, a moisture barrier coating 70 is additionally formed for preventing moisture from penetrating into the wavelength converter 60a, as described above with reference to FIG. 6. For example, the moisture barrier coating 70 may be formed after the removal of the wavelength converter 60a and the remaining underfill 40a under the cut region. The moisture barrier coating 70 may be formed before or after the cutting of the second substrate 51.

[0071] According to this embodiment, the light extraction efficiency may be improved by forming the surface texture T on the rear surface of the first substrate 21. In addition, the light extraction efficiency may be further improved by cutting the first substrate 21 such that the lateral side of the first substrate 21 is inclined. The technique for forming the surface texture T and forming the inclined lateral side is not limited to this embodiment, but may be equally applied to other embodiments.

[0072] Meanwhile, in this embodiment, since the wavelength converter 60a is formed after the partial removal of the first substrate 21 and the underfill 40a, the wavelength converter 60a may be formed to cover the lateral sides of the semiconductor stacks 30.

[0073] FIGS. 13 to 16 are cross-sectional views illustrating a method of fabricating an LED package according to another embodiment of the present invention.

[0074] Referring to FIG. 13, after the wafer 20 is coupled to the package member 50, the surface texture T is formed on the rear surface of the first substrate 21, and the first substrate 21 is cut such that the lateral side thereof is inclined, as described above with reference to FIGS. 8 and 9. However, in this embodiment, the process of forming the underfill 40a in the wafer preparing step is skipped, as opposed to the previous embodiments.

[0075] Referring to FIG. 14, a wavelength converter 60b covering the cut first substrate 21 is formed. In addition, the wavelength converter 60b may fill a gap between the first substrate 21 and the second substrate 51. That is, the underfill 40a may also be formed using the wavelength converter 60b. The wavelength converter 60b may be formed of a phosphor-containing resin. Alternatively, the wavelength converter 60b may be formed on the first substrate 21 at a uniform thickness by using a squeeze.

[0076] Referring to FIG. 15, the second substrate 51 is cut, and therefore, the fabrication of individual LED packages is completed. The wavelength converter 60b disposed within the cut region of the first substrate 21 may also be cut.

[0077] Referring to FIG. 16, a moisture barrier coating 70 is additionally formed for preventing moisture from penetrating into the wavelength converter 60b, as described above with reference to FIG. 6. For example, after the wavelength converter 60b under the cut region is removed, the moisture barrier coating 70 may be formed to cover the wavelength converter 60b. The moisture barrier coating 70 may be formed before or after the cutting of the second substrate 51.

[0078] While the embodiments of the present invention have been described with reference to the specific embodiments, it will be apparent to those skilled in the art that various changes and modifications may be made without departing from the scope of the invention as defined in the following claims.

Claims

1. A wafer level light emitting diode (LED) package comprising:
   a first substrate (21);
   a semiconductor stack (30) disposed on a front surface of the first substrate (21), the semiconductor stack (30) comprising a first-conductivity-type semiconductor layer (25), a second-conductivity-type semiconductor layer (29), and an active layer (27) disposed between the first-conductivity-type semiconductor layer (25) and the second-conductivity-type semiconductor layer (29);
a second substrate (51) comprising a first lead electrode (53a) and a second lead electrode (53b);
a plurality of connectors (37a, 37b) electrically connecting the semiconductor stack (30) to the first (53a) and second (53b) lead electrodes; and
a wavelength converter (60) covering a rear surface of the first substrate (21),
characterized by
a moisture barrier coating (70), in contact with the second substrate (51), covering the wavelength converter (60).

2. The wafer level LED package of claim 1, further comprising:
an underfill (40a) disposed between the first substrate (21) and the second substrate (51).

3. The wafer level LED package of claim 2, wherein the underfill (40a) comprises at least one of a phosphor and a filler.

4. The wafer level LED package of claim 2, wherein the wavelength converter (60) covers at least a portion of a lateral side of the underfill (40a).

5. The wafer level LED package of claim 1, wherein the moisture barrier coating (70) covers a lateral side of the underfill (40a).

6. The wafer level LED package of claim 1, wherein the moisture barrier coating (70) has a structure in which an organic material layer (71) and an inorganic material layer (73) are alternately laminated.

7. The wafer level LED package of claim 1, wherein the wavelength converter (60) fills a gap between the first substrate (21) and the second substrate (51).

8. The wafer level LED package of claim 1, wherein the wavelength converter (60) comprises a phosphor-containing glass.

9. The wafer level LED package of claim 8, wherein the glass is directly bonded to the rear surface of the first substrate (21).

10. The wafer level LED package of claim 9, wherein a surface texture for improving a light extraction efficiency is formed on the rear surface of the first substrate (21).

11. The wafer level LED package of claim 9, wherein a lateral side of the first substrate (21) is inclined with respect to a vertical direction of the back side of the first substrate.

2. Wafer-Level-Leuchtdioden (LED)-Package, umfassend:
ein erstes Substrat (21);
ein Halbleiterstab (30), der auf einer Vorderseite des ersten Substrats (21) angeordnet ist, wobei der Halbleiterstab (30) eine Halbleiterschicht (25) eines ersten Leitfähigkeitstyps, eine Halbleiterschicht (29) eines zweiten Leitfähigkeitstyps und eine aktive Schicht (27), die zwischen der Halbleiterschicht (25) des ersten Leitfähigkeitstyps und der Halbleiterschicht (29) des zweiten Leitfähigkeitstyps angeordnet ist, umfasst;
ein zweites Substrat (51), das eine erste Zuleitungselektrode (53a) und eine zweite Zuleitungselektrode (53b) umfasst;
mehrere Verbinde (37a, 37b), die den Halbleiterstab (30) mit der ersten (53a) und der zweiten (53b) Zuleitungselektrode elektrisch verbinden;
den Wellenlängenwandler (60), der eine Rückseite des ersten Substrats (21) bedeckt, gekennzeichnet durch
einen Feuchtigkeitsperrbeschichtung (70), die mit dem zweiten Substrat (51) in Kontakt steht und den Wellenlängenwandler (60) bedeckt.

2. Wafer-Level-LED-Package nach Anspruch 1, des Weiteren umfassend:
eine Unterfüllung (40a), die zwischen dem ersten Substrat (21) und dem zweiten Substrat (51) angeordnet ist.

3. Wafer-Level-LED-Package nach Anspruch 2, wobei die Unterfüllung (40a) mindestens eines von einem Phosphor und einem Füllstoff umfasst.

4. Wafer-Level-LED-Package nach Anspruch 2, wobei der Wellenlängenwandler (60) mindestens einen Abschnitt einer lateralen Seite der Unterfüllung (40a) bedeckt.

5. Wafer-Level-LED-Package nach Anspruch 1, wobei die Feuchtigkeitsperrbeschichtung (70) eine laterale Seite der Unterfüllung (40a) bedeckt.

6. Wafer-Level-LED-Package nach Anspruch 1, wobei die Feuchtigkeitsperrbeschichtung (70) eine Struktur hat, in der eine organische Materialschicht (71) und eine anorganische Materialschicht (73) abwechselnd laminiert sind.

7. Wafer-Level-LED-Package nach Anspruch 1, wobei der Wellenlängenwandler (60) einen Spalt zwischen dem ersten Substrat (21) und dem zweiten Substrat
8. Wafer-Level-LED-Package nach Anspruch 1, wobei der Wellenlängenwandler (60) ein Phosphor-haltiges Glas umfasst.

9. Wafer-Level-LED-Package nach Anspruch 8, wobei das Glas direkt an die Rückseite des ersten Substrats (21) gebondet ist.

10. Wafer-Level-LED-Package nach Anspruch 9, wobei eine Oberflächentextur zum Verbessern einer Lichtauskopplungs effizienz auf der Rückseite des ersten Substrats (21) ausgebildet ist.

11. Wafer-Level-LED-Package nach Anspruch 9, wobei eine laterale Seite des ersten Substrats (21) mit Bezug auf eine vertikale Richtung der Rückseite des ersten Substrats geneigt ist.

Revidications

1. Boîtier de diode électroluminescente (LED) sur tranche comprenant :
   un premier substrat (21) ;
   un empilement semi-conducteur (30) disposé sur une surface avant du premier substrat (21), l’empilement semi-conducteur (30) comprenant une couche semi-conductrice d’un premier type de conductivité (25), une couche semi-conductrice d’un second type de conductivité (29), et une couche active (27) disposée entre la couche semi-conductrice du premier type de conductivité (25) et la couche semi-conductrice du second type de conductivité (29) ;
   un second substrat (51) comprenant une première électrode conductrice (53a) et une seconde électrode conductrice (53b) ;
   une pluralité de connecteurs (37a, 37b) reliant électriquement l’empilement semi-conducteur (30) aux première (53a) et seconde (53b) électrodes conductrices ;
   et un convertisseur de longueur d’onde (60) recouvrant une surface arrière du premier substrat (21), caractérisé par un revêtement de barrière contre l’humidité (70), en contact avec le second substrat (51), recouvrant le convertisseur de longueur d’onde (60).

2. Boîtier de LED sur tranche selon la revendication 1, comprenant en outre :
   une résine de remplissage (40a) disposée entre le premier substrat (21) et le second substrat (51).

3. Boîtier de LED sur tranche selon la revendication 2, dans lequel la résine de remplissage (40a) com- prend au moins l’un d’un phosphore et d’une charge.

4. Boîtier de LED sur tranche selon la revendication 2, dans lequel le convertisseur de longueur d’onde (60) recouvre au moins une partie d’un côté latéral de la résine de remplissage (40a).

5. Boîtier de LED sur tranche selon la revendication 1, dans lequel le revêtement de barrière contre l’humidité (70) recouvre un côté latéral de la résine de remplissage (40a).

6. Boîtier de LED sur tranche selon la revendication 1, dans lequel le revêtement de barrière d’humidité (70) a une structure dans laquelle une couche de matériau organique (71) et une couche de matériau inorganique (73) sont stratifiées alternativement.

7. Boîtier de LED sur tranche selon la revendication 1, dans lequel le convertisseur de longueur d’onde (60) remplit un espace entre le premier substrat (21) et le second substrat (51).

8. Boîtier de LED sur tranche selon la revendication 1, dans lequel le convertisseur de longueur d’onde (60) comprend un verre contenant du phosphore.

9. Boîtier de LED sur tranche selon la revendication 8, dans lequel le verre est directement lié à la surface arrière du premier substrat (21).

10. Boîtier de LED sur tranche selon la revendication 9, dans lequel une texture de surface destinée à améliorer une efficacité d’extraction de lumière est formée sur la surface arrière du premier substrat (21).

11. Boîtier de LED sur tranche selon la revendication 9, dans lequel un côté latéral du premier substrat (21) est incliné par rapport à une direction verticale du côté arrière du premier substrat.
REFERENCES CITED IN THE DESCRIPTION

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Patent documents cited in the description

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